



EFK

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q76028

Yasuhiro IJIMA

Appln. No.: 10/628,459

Group Art Unit: 3765

Confirmation No.: 4842

Examiner: Hiteshew, Felisa Carla

Filed: July 29, 2003

For: METHOD OF PRODUCING A POLYCRYSTALLINE THIN FILM AND A METHOD  
OF PRODUCING AN OXIDE SUPERCONDUCTING ELEMENT

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 31, 2006, please amend the above-identified application as follows on the accompanying pages.

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